



PATENT APPLICATION

FW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date July 17, 2007

In re the Application of

Sadayoshi HORII et al.

Group Art Unit: 1763

Application No.: 10/529,466

Examiner: R. BUEKER

Filed: March 29, 2005

Docket No.: 123373

For: MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE AND SUBSTRATE
PROCESSING APPARATUS

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired April 17, 2007, an extension of time for a period of 3 months is hereby requested. Attached hereto is our Check No. 194921 in the amount of \$1020 in payment for:

_____	Extension fee for response within first month pursuant to §1.136(a) (\$120.00)
_____	Extension fee for response within second month pursuant to §1.136(a) (\$450.00)
<u>X</u>	Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1020.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,

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JAO:JXT/ldg

1020.00 00

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DEPOSIT ACCOUNT USE
AUTHORIZATION
Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461